

Reply under 37 CFR 1.116
Expedited Procedure - TC 1762

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/805,620
Confirmation No. 3004
Filing Date March 13, 2001
Inventor Craig M. Carpenter
Assignee Micron Technology, Inc.
Group Art Unit 1762
Examiner Kelly M. Stouffer
Attorney's Docket No. MI22-1563
Customer No. 021567
Title: Chemical Vapor Deposition Methods (Amended)

RESPONSE TO JULY 25, 2007 FINAL OFFICE ACTION
UNDER 37 CFR 1.116(b)

To: MS AF
Commissioner for Patents
P.O. Box 1450
Art Unit 1762
Alexandria, VA 22313-1450

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

AMENDMENTS